



LFW
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JAN RAEBIGER
HEIKO WAGNER
UWE SCHULZE
ROLF SELTMANN

Examiner: Alan A. Mathews

Group Art Unit: 2851

Serial No.: 10/625,451

Att'y Docket: 2000.108200/DE0353

Filed: July 23, 2003

Customer No.: 23720

For: METHOD AND SYSTEM FOR
IMPROVING EXPOSURE
UNIFORMITY IN A STEP AND
REPEAT PROCESS

RESPONSE TO OFFICE ACTION DATED DECEMBER 27, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

April 26, 2005

Date

May Paul
Signature

This paper is submitted in response to the Office Action dated December 27, 2004, for which the three-month date for response was March 27, 2005. A request for a one-month extension of time to respond is included herewith. This one-month extension will bring the due date to April 27, 2005, which is within the six-month statutory period.

A fee in the amount of \$120 is believed to be due in connection with the present response. **The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R. §§ 1.16 to 1.21, from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0353.** In the event the monies in that account are insufficient, the Director is

authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.108200.

Reconsideration of the application in view of the following amendments and remarks is respectfully requested.